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S/N 10/692,881

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Sharone Gindel	Examiner:	Saeed T. Chaudhry
Serial No.:	10/692,881	Group Art Unit:	1744
Filed:	October 24, 2003	Docket No.:	884.422US2
Title:	VACUUM DEBRIS REMOVAL SYSTEM FOR AN INTEGRATED CIRCUIT MANUFACTURING DEVICE		
Assignee:	Intel Corporation	Customer No: 21186	

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

This responds to the Office Action mailed on November 5, 2004. Please amend the above-identified patent application as follows.